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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Toshihiro HAYAMI, et al.  
Serial No.: 10/775,145 Art Unit: 1792  
Filed: February 11, 2004 Examiner: Maureen Gramaglia Arancibia  
For: PLASMA PROCESSING UNIT AND HIGH-FREQUENCY ELECTRIC POWER  
SUPPLYING UNIT

SECOND INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to the duty of disclosure under 37 C.F.R. 1.56, Applicants enclose an Information Disclosure Citation Form (PTO-1449) and copies of the documents cited therein. Also, U.S. Publication No. 2005-0011452 is the counterpart to WO 03/046959.

It is respectfully requested that the cited documents be considered by the Examiner, that they be made officially of record therein, and that the documents be listed on the face of any patent which may issue from this application.

Further, Applicants certify under 37 C.F.R. 1.97(e)(1) that each item of information contained in the information disclosure statement was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the information disclosure statement. Therefore, it is believed that no fees are due under 37 C.F.R. Section 1.97(b)(3).

Respectfully submitted,  
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